

First experimental demonstration of S-band large-signal performance for GaN HBTs

Selective-area emitter technology and device scaling yield record 30.5GHz f_T and 7.01GHz f_{max} in GaN HBTs, with a first-reported S-band output power density of 16.5kW/cm²

A Chinese research team has achieved consecutive breakthroughs in gallium nitride (GaN) heterojunction bipolar transistors (HBTs), with results published in IEEE Electron Device Letters (IEEE EDL) in both 2025 and 2026. The 2026 paper was selected as an Editor's Pick, marking a transition for GaN HBTs from frequency characterization to practical power application evaluation.

Due to their vertical current transport structure and the high critical electric field inherent to wide-bandgap materials, GaN-based HBTs offer significant theoretical advantages for high-power, high-frequency RF applications. However, compared to commercially established gallium arsenide (GaAs) HBTs and rapidly advancing GaN high-electron-mobility transistors (HEMTs), the RF performance of GaN HBTs has long been stagnant, with cut-off frequency (f_T) and maximum oscillation frequency (f_{max}) previously limited to around 8GHz and

1.8GHz, respectively. The primary bottlenecks were twofold: the high resistivity of the p-type GaN base layer and surface damage from dry etching, which caused Schottky-like base contacts and high base resistance (R_B),

severely limiting f_{max} ; and high emitter contact resistance (R_{E-M}) in scaled devices, which increased collector charging time (τ_C) and limited f_T .

In 2025, the team published a paper 'AlGaN/GaN Heterojunction Bipolar Transistors With Record $f_T/f_{max} = 21.6/4.23\text{GHz}$ ' (L. Zhang et al, IEEE Electron Device Letters, 46(6), 912–915, 2025), marking the first time that GaN HBT frequencies were pushed into the S-band. This breakthrough was achieved through three key technological innovations. First, the team employed a selective-area epitaxial emitter technology, avoiding the base etching process and successfully achieving ohmic base contacts for the first time, with a specific contact resistivity of $3.23 \times 10^{-3} \Omega \text{ cm}^2$. Second, they introduced a heavily doped n^+ -GaN emitter cap layer, reducing the specific emitter contact resistivity to $1.35 \times 10^{-7} \Omega \text{ cm}^2$ and effectively lowering the collector

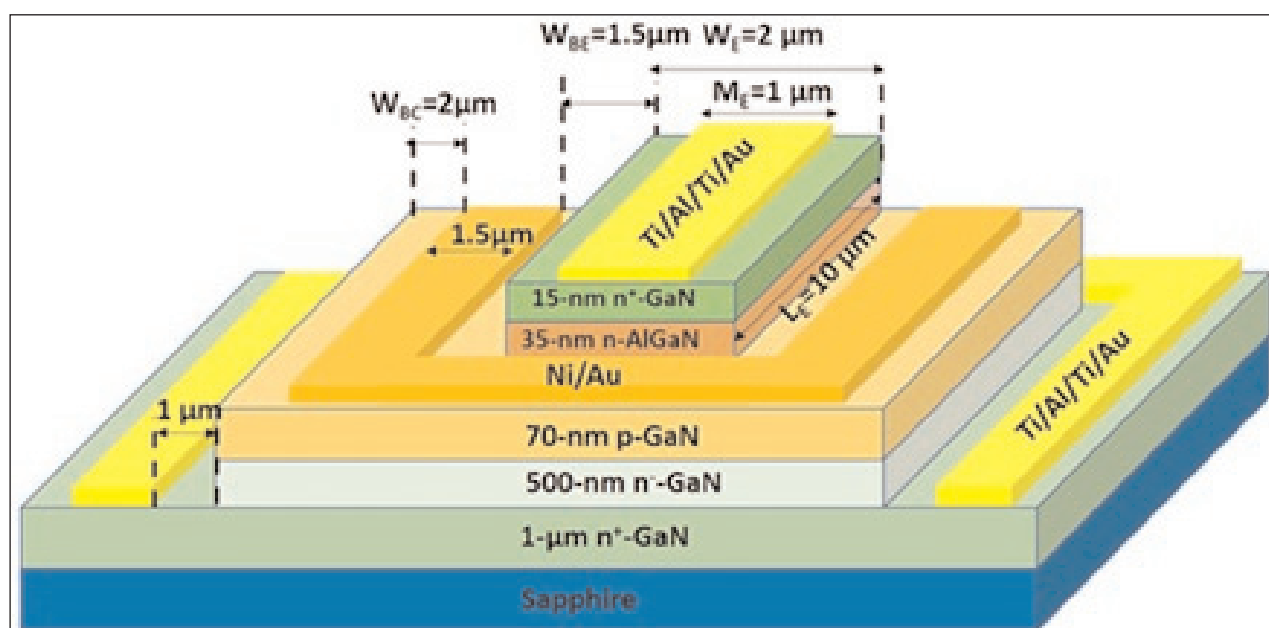


Figure 1: Schematic diagram of the GaN HBT with SAG n-AlGaIn emitter.

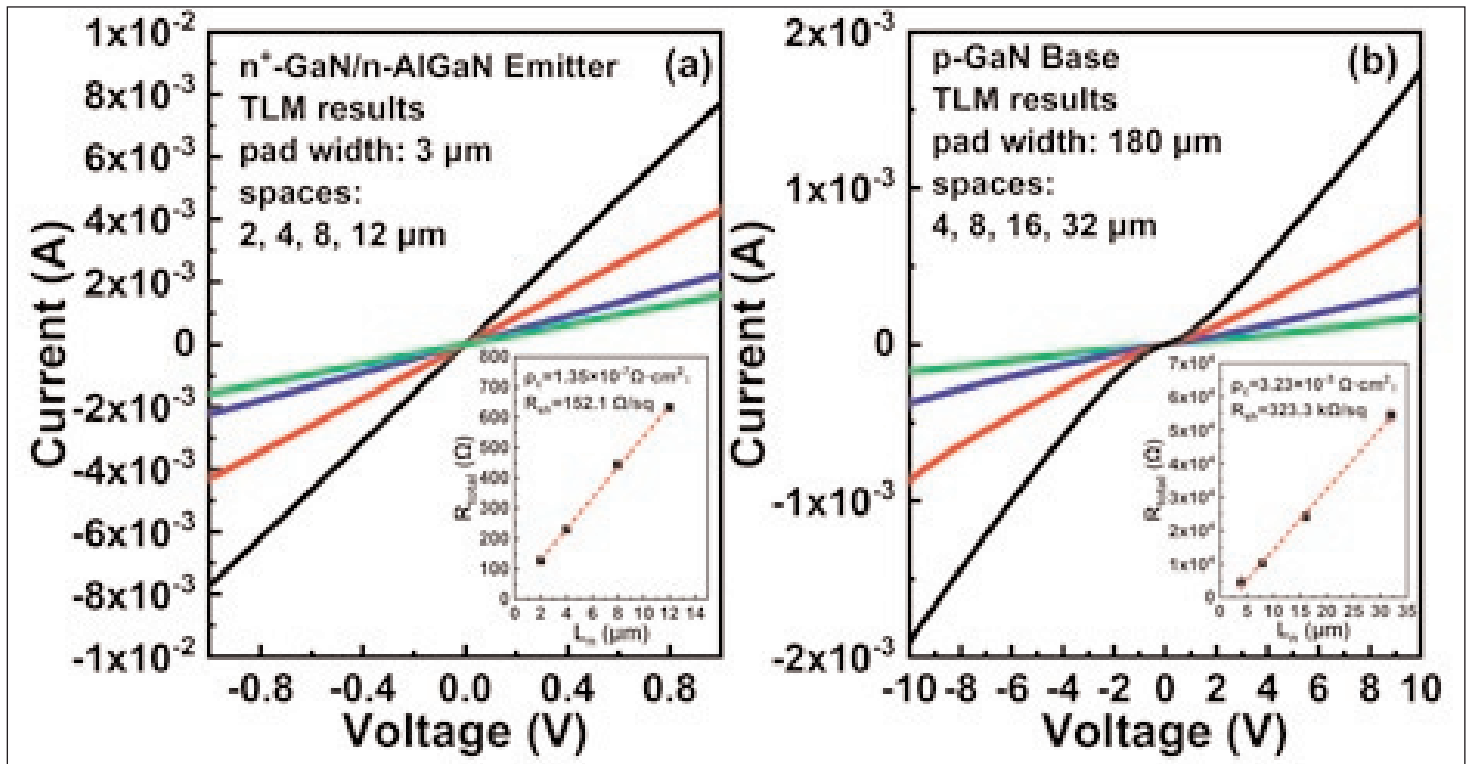


Figure 2: The I-V curves and resistance of the TLM structure on the regrown emitter layer and base layer.

charging time. Third, critical dimensions such as the base-emitter spacing were scaled down, further reducing parasitic resistances and capacitances. The resulting device demonstrated a record f_T of 21.6GHz and f_{max} of 4.23GHz. The base-to-collector electron transit time was reduced to 6.9ps, only one-quarter of previously reported values. This device also achieved the highest recorded values for GaN HBTs on sapphire substrates: a saturated current density of 91.9kA/cm², and a DC power density of 1.31MW/cm².

In 2026, the team published a follow-up paper 'Experimental Demonstration of S-Band Gallium Nitride

Heterojunction Bipolar Transistors With $P_{\text{out}} = 16.5\text{kW/cm}^2$ ' (L. Zhang et al, IEEE Electron Device Letters, 47(7), 1306-1309, 2026), which was selected as an 'Editor's Pick'. This work further pushed the frequency and power records of GaN HBTs. Building on the 2025 results, the team adopted a high-aspect-ratio emitter design, increasing the emitter area to $3 \times 80 \mu\text{m}^2$ to reduce emitter contact resistance and on-resistance, thereby enhancing power output capability. Critically, the team systematically investigated the impact of the base-emitter spacing (W_{BE}) on device performance. Reducing W_{BE} from $2 \mu\text{m}$ to $1 \mu\text{m}$ resulted in a 67%

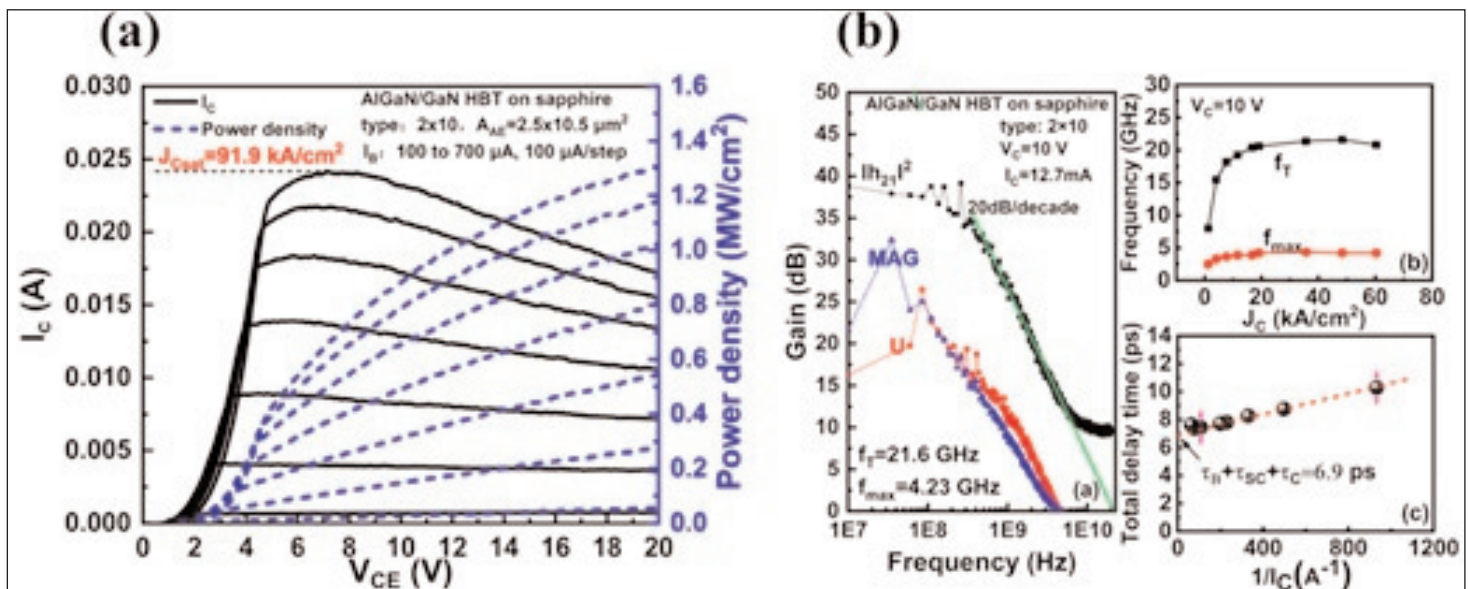


Figure 3: The AlGaIn/GaN HBT with design $A_E = 2 \times 10 \mu\text{m}^2$: (a) common-emitter family curves; (b) the frequency performance and the fitted delay time.

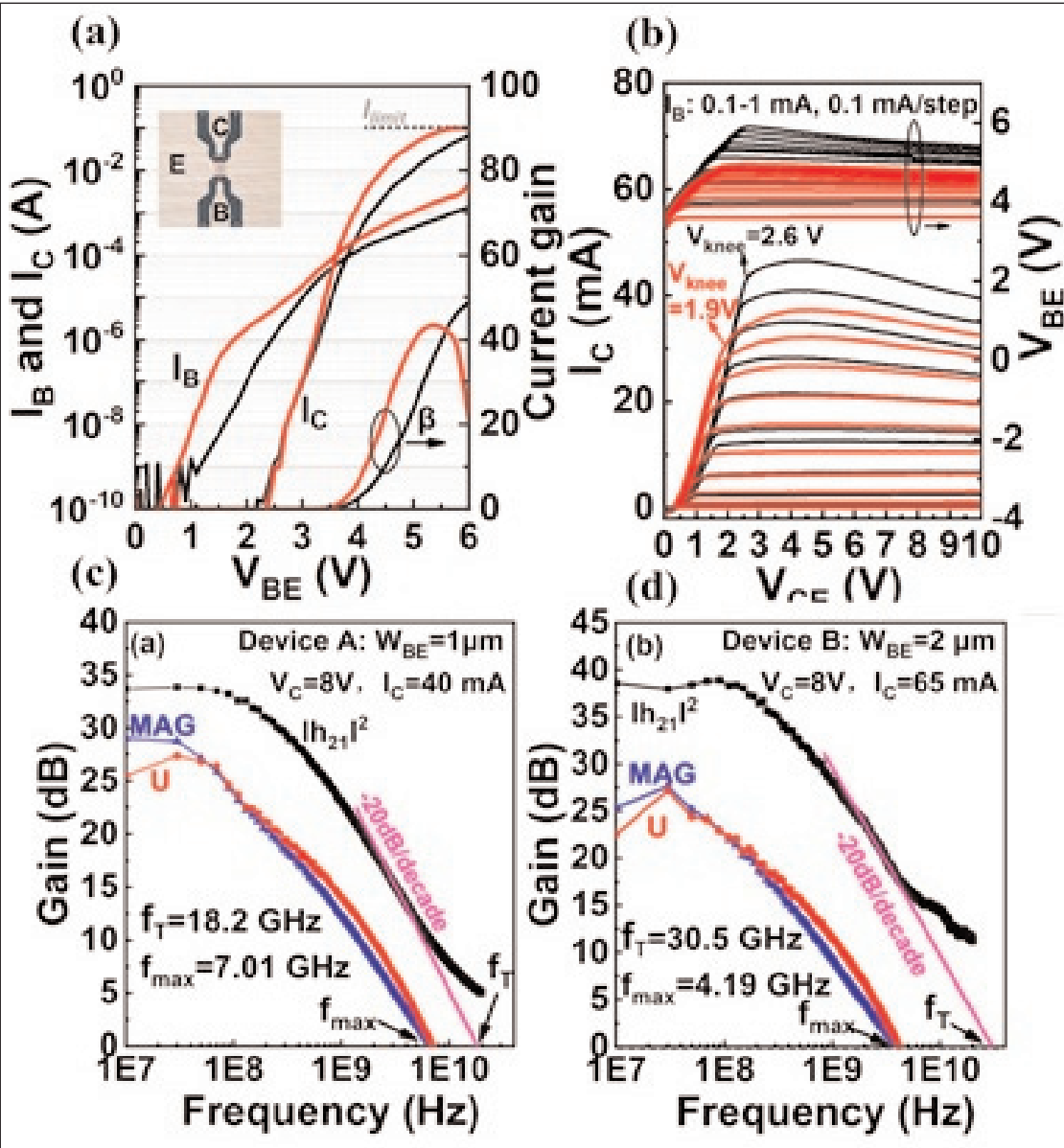


Figure 4: Measured characteristics of the GaN HBTs with different base-emitter spacing: (a) Gummel plot curves; (b) family curves; (c) and (d) frequency performance.

increase in f_{max} , from 4.19 GHz to a record 7.01 GHz for GaN HBTs. Devices with $W_{BE} = 2 \mu m$ achieved a record f_T of 30.5 GHz, the highest ever reported for a GaN HBT. For power characterization, the team performed continuous-wave large-signal load-pull measurements in the S-band. At 2.4 GHz and $V_{CE} = 10$ V, the scaled device demonstrated an output power density of 16.5 kW/cm^2 . This is the first experimental demonstration of S-band large-signal performance for a GaN HBT, confirming the inherent high-power-density advantage of the vertical structure.

Through the systematic adoption of selective-area epitaxial emitter technology, the introduction of a heavily doped cap layer, and the scaling of device dimensions, the team has systematically addressed the parasitic resistance bottlenecks that have long constrained GaN HBT RF performance. The team states that future work, including the use of SiC or GaN substrates for improved thermal management and further optimization of device dimensions and structure, holds promise for significantly enhancing power-added efficiency (PAE) and advancing the practical application of GaN HBTs in S-band power amplifiers. ■

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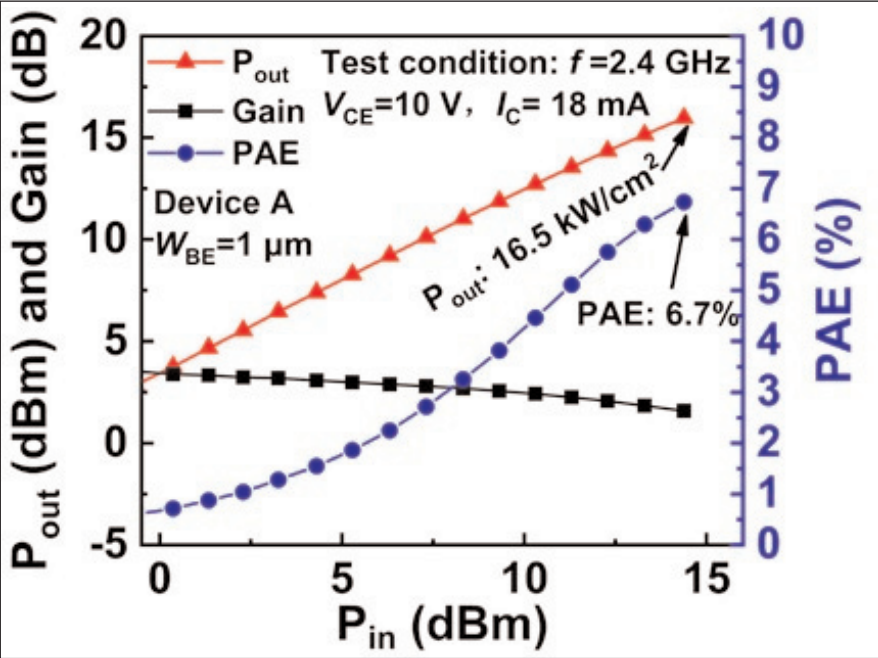


Figure 5: Large-signal performance of the GaN HBT.